H. Toshiyoshi/A. TIXIER-MITA LAB.

[MEMS/NEMS]

Centre for Interdisciplinary Research
on Micro-Nano Methods

Micro Machine System Engineering
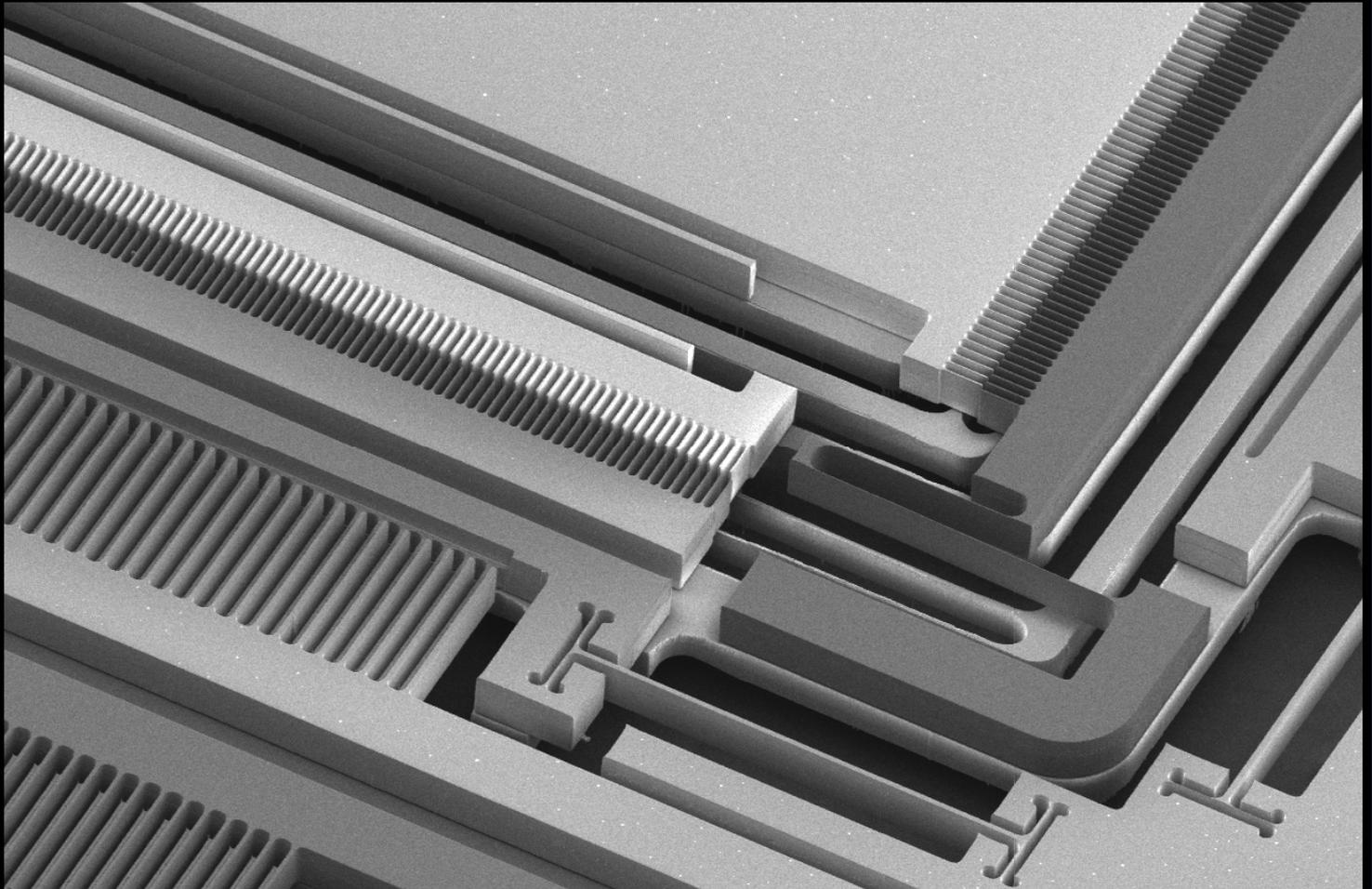
Electrical Engineering course
Department of Electrical Engineering and Information Systems

http://toshi.iis.u-tokyo.ac.jp/toshilab

Comme Ça de MEMS
MEMS Actuators and Sensors

Semiconductor MEMS sensors, actuators, energy harvesters and bio-sensing are our research interests. Regardless your status of students or corporate researchers, anyone who is interested in multiple technical layers from materials, processes, devices, systems through IoT services is welcomed here, where your technological perspectives are cultivated.

Institute of Industrial Science, The University of Tokyo